

Docket No.: 4887P446D

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

STEVEN VERHAVERBEKE, ET AL.

Application No.: 10/616,093

July 8, 2003 Filed:

For: Assisted Rinsing in a Single Wafer Cleaning

Process

Art Group: 1746

Examiner: Markoff, Alexander

PETITION FOR EXTENSION OF TIME PURSUANT TO 37 C.F.R. § 1.136(a)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F. R. § 1.136(a), Applicants for the above-identified application respectfully Petition the Commissioner for a one (1) month extension of time, extending the period for response to January 22, 2007, from the Final Office Action dated September 20, 2006. The petition filing fee of \$120.00 and an Amendment and Response to Final Office Action and Request for Continued Examination (RCE) are attached. (If a check is not attached, you are hereby authorized to charge deposit account no. 02-2666.)

If it should be determined that a longer extension of time is required to prevent this application from being abandoned, please charge any additional fees to Deposit Account No. 02-2666. A copy of the Fee Transmittal is enclosed for deposit account charging purposes.

Respectfully submitted,

Blakely, Sokoloff, Taylor & Zafman LLP

Date: 1-22-07

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Neal Berezny, Reg. No. 56,030

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CERTIFICATE: OF MAILING/TRANSMISSION

I hereby certify that this correspondence is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA

22313-1450.